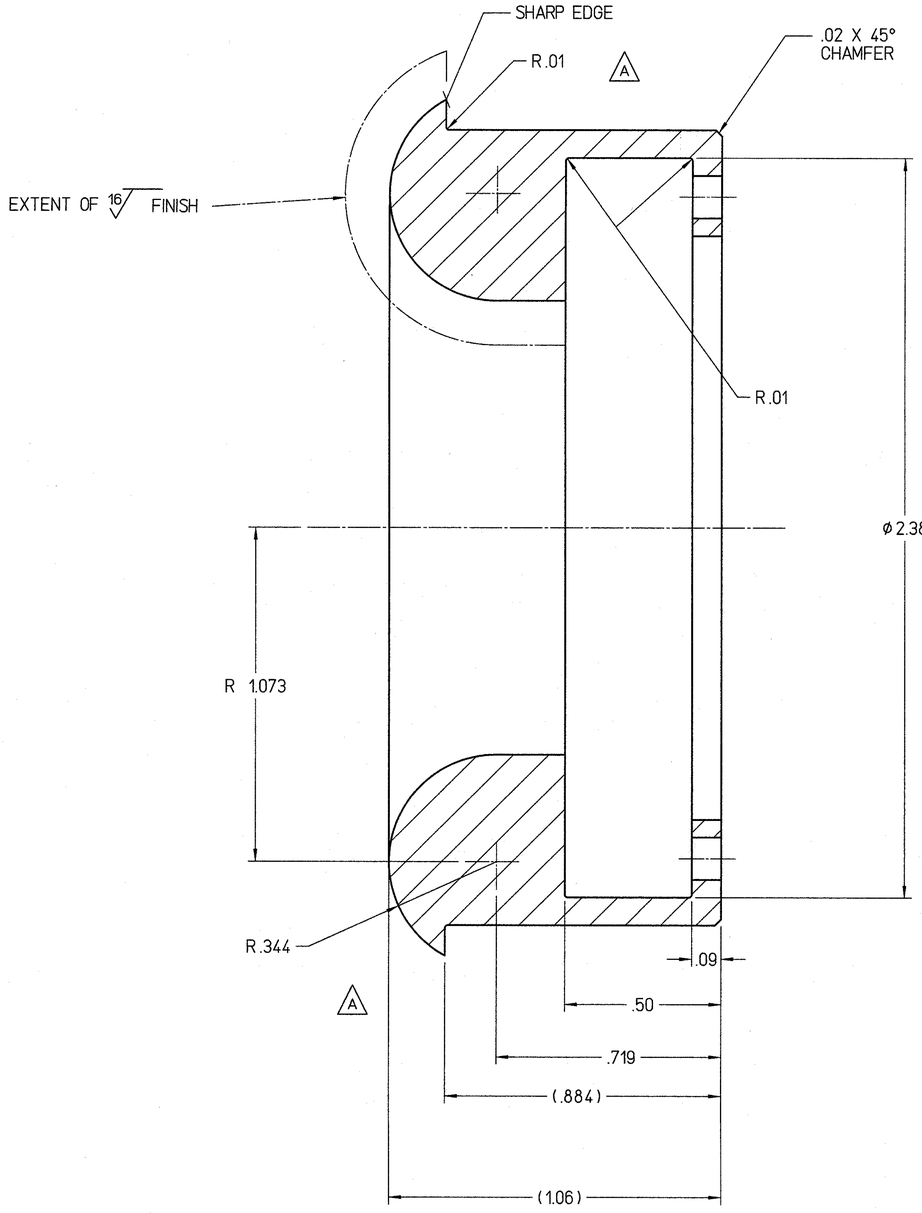
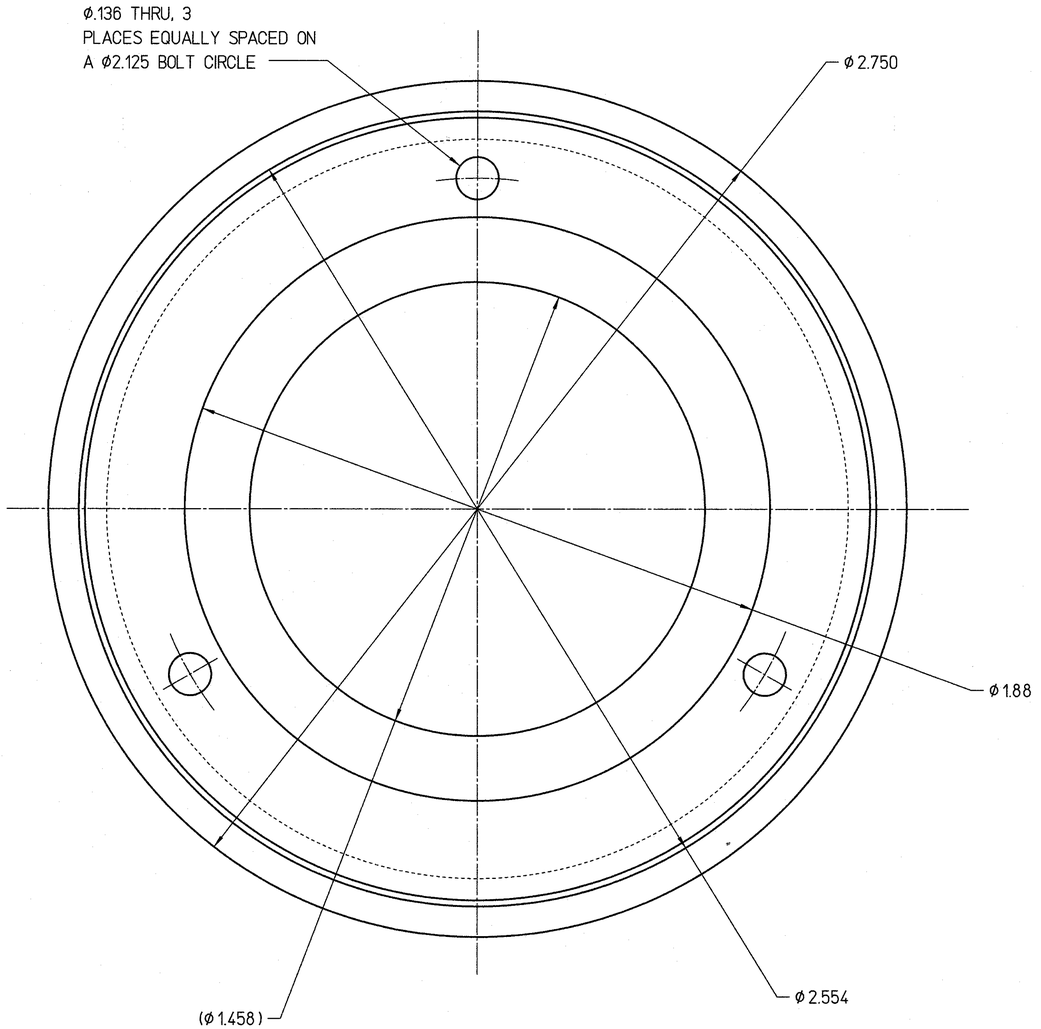
REVISION HISTORY				
ZONE	REV	DESCRIPTION	DATE	APPROVED
ALL	A	REMOVED UNDERCUT ON O.D. DM 3/12/12	3/12/12	





NOTES:

1. USE THE FOLLOWING JLAB SPECIFICATIONS
   FABRICATION OF ULTRA HIGH VACUUM EQUIPMENT: #22631-S-001
   CLEANING AND HANDLING OF U.H.V. COMPONENTS: #22632-S-001
2. MATERIAL SHALL BE SINGLE GRAIN OR FINE GRAIN NIOBIUM.
3. AFTER FINAL MACHINING, BCP ITEM. CHEMICAL ETCHING ALLOWANCE IS .004 PER SURFACE.

QTY. REQD	ITEM NO.	PART OR IDENTIFYING NO.	NOMENCLATURE OR DESCRIPTION	MATERIAL SPECIFICATION	NOTES
PARTS LIST					

DOCUMENT CONTROL STAMP

MATERIAL: SEE NOTES

FINISH MACHINED SURFACES 63 UNLESS OTHERWISE NOTED
DEBURR & BREAK ALL SHARP EDGES

DO NOT SCALE DRAWING

DIM & TOL PER ASME Y14.5
UNLESS OTHERWISE SPECIFIED
DIMENSIONS ARE IN INCHES
TOLERANCES ARE:
FRACTIONS ± DECIMAL X ± XX ± .01 XXX ± .003 ANGLES ± .50°

THIRD ANGLE PROJECTION

TRACKING NO. N/A

APPROVALS	DATE
DRAWN D. MACHIE	10FEB12
CHECKED B. MATT POELKER	2/17/12
APPROVED B. MATT POELKER	2/17/12
APPROVED J. HANSKNECHT	2/17/12

U.S. Department of Energy, Office of Science — Jefferson Lab, Thomas Jefferson National Accelerator Facility — Operated by Jefferson Science Associates, LLC

ACC INJECTOR LOAD LOCK GUN ELECTRODE BACK END

SIZE	DWG. NO.	REV.
D	ACC-200-3000-0462	A

SCALE 4:1 | USED ON ASSY NO. ACC-200-3000-0464 | SHEET 1 OF 1

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